Ultrafast Epitaxial Growth Kinetics in Functional Oxide Thin Films Grown by Pulsed Laser Annealing of Chemical Solutions

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ABSTRACT: The crystallization process and physical properties of different functional oxide thin films (Ce0.9Zr0.1O2-y, LaNiO3, Ba0.8Sr0.2TiO3, and La0.7Sr0.3MnO3) on single crystal substrates (Y2O3, ZrO2, LaAlO3 and SrTiO3) are studied by pulsed laser annealing (PLA). A Nd:YAG laser source (λ=266 nm, 10 Hz and τ~3 ns) is employed to crystallize chemical solution deposited (CSD) amorphous/nanocrystalline films in atmospheric conditions. We provide new insight on the influence of photochemical and photothermal interactions on the epitaxial crystallization kinetics of oxide thin films during the transformation from amorphous/polycrystalline material (i.e. atomic diffusion, epitaxial growth rates and activation energies of nucleation and crystallization). The epitaxial growth is investigated by varying the laser fluence and the applied number of pulses. The morphology, structure and epitaxial evolution of films are evaluated by means of atomic force and transmission electron microscopies, and X-ray diffraction. Highly epitaxial oriented films of 20-40 nm in thickness are obtained by PLA. The crystallization kinetics of laser treatments is determined to be orders of magnitude faster than thermal treatments with similar activation energies (1.5-4.1 eV), mainly due to the large temperature gradients inducing modified atomic diffusion mechanisms derived mainly from photothermal interactions, as well as a minor contribution of photochemical effects. The fast heating rates achieved by PLA also contribute to the fast epitaxial growth due to reduced coarsening of polycrystalline material. The measurement of the physical properties (electrical resistivity and magnetism) of laser processed CSD films has revealed significantly good functionalities, close to those of thermally grown films, but with much shorter processing times.

1. INTRODUCTION
Crystallization of functional oxide is a central topic in materials science that has drawn much attention in the past decades. Especially, thanks to the development of nanoscience and nanotechnology which have allowed the production of dimensionally constrained materials with great potential for multiple applications and outstanding physical properties in fields such as ferromagnetism, ferroelectricity, colossal magnetoresistance, multiferroicity, superconductivity or photocatalysis.1-6 Solution-based methods like the chemical solution deposition (CSD) have demonstrated high versatility, cost-effectiveness and scalability in the fabrication of highly crystalline functional oxide heterostructures with complex compositions as compared to more established physical methods (sputtering or pulsed laser deposition).7-9 Oxide crystallization by CSD involves the use of high temperature thermal treatments which are time consuming and limit their growth on temperature sensitive substrates. Over the last decades, laser irradiation, also known as laser annealing, has arisen as an alternative processing methodology to avoid the constraints of pure thermal techniques for materials processing due to the fast, versatile and localized nature of lasers.10 Laser systems working in continuous wave (CW) or pulsed modes at wavelengths in the infrared (IR), visible (Vis) and ultraviolet (UV) ranges, have been employed to induce complex phenomena. For instance, laser-induced local diffusion of species has been reported to be key in the growth of TiN microcolumns and Cu films from CuO nanoparticles with CW and pulsed IR lasers (Nd:YAG and Yb-doped fiber lasers),11, 12 but also in InGaAs/GaAs quantum dots and RblA NbO2 films using pulsed UV excimer lasers.13-14 CW and pulsed diode and Nd:YAG lasers with wavelengths in the IR and UV range have also been used for the decomposition of metalorganic solutions, the densification of sol-gel films, and the fabrication of crystalline
Laser crystallization of CSD precursor films has been mostly investigated for a broad range of polycrystalline oxides such as ZrO$_2$, TiO$_2$, undoped and Sn-doped InO$_x$, Ba$_{1-x}$Sr$_x$TiO$_3$ (x=0.2 and 0.3) and (Pb,La)(Zr,Ti)O$_3$ using diode, excimer and Nd:YAG lasers in the IR, Vis and UV ranges. In addition, some works have grown polycrystalline Al-doped ZnO from sputtered amorphous films with IR diode and UV excimer lasers in CW and pulsed modes. Nevertheless, UV lasers are the best choice for oxide crystallization due to their large absorption at those wavelengths. Tsuchiya et al. have reported successful epitaxial growth with oxides like VO$_2$, perovskite manganites (LMO, LSMO), Pb(Zr,Ti)O$_3$ and YBa$_2$Cu$_3$O$_y$ using UV excimer lasers. In addition, we have also reported growth of epitaxial oxides like Ce$_{0.9}$Zr$_{0.1}$O$_{1.95}$ and Ba$_{0.8}$Sr$_{0.2}$TiO$_3$. These works have proposed different approaches to investigate the fundamental thermodynamic and kinetic principles of laser crystallization of CSD films. However, there are still some open questions that we wanted to investigate further. Essentially, a general overview that evaluates the extent to what photochemical and photothermal interactions influence the laser crystallization kinetics (i.e. atomic diffusion and activation energies) which depends on the type of laser employed; but also how this kinetics compares to that of thermal annealing. In this work, we aim to provide additional insights on the underlying laser epitaxial crystallization mechanisms by comparing different oxide thin films and their functional properties, but also with equivalent films crystallized with thermal treatments. We want to understand the fast transformation from the decomposed metalorganic chemical precursors to the epitaxial film crystallization. We have chosen the following high performant functional oxide materials for our study: zirconium-doped ceria (Ce$_{0.9}$Zr$_{0.1}$O$_{1.95}$ or CZO), which can be used as dielectric component in electronic devices or as a buffer layer for high temperature superconducting coated conductors since it has high mechanical and chemical stability, and high dielectric constant. 

Lanthanum nickelate (LaNiO$_3$ or LNO) is a highly metallic oxide at room temperature that can be employed as an electrode to integrate other oxide materials in electronic devices, and it also presents interesting photoelectrocatalytic properties for water splitting applications. We have also studied barium strontium titanate (Ba$_{0.8}$Sr$_{0.2}$TiO$_3$ or BST) which is a well-known ferroelectric at room temperature (when Ba/Sr ratio is above 0.7/0.3) and has remarkable optical and dielectric properties. Thus, it is suitable for applications such as non-linear optics, infrared detectors, thermal imaging, microwave dielectrics or capacitors.

Finally, lanthanum strontium manganese (La$_{1-x}$Sr$_{x}$MnO$_3$ or LSMO) is an oxide material with physical properties such as room temperature ferromagnetism and metallic conductivity or colossal magnetoresistance that presents resistive switching and it has recently been discovered as an interesting candidate for non-volatile resistive random access memories (NVRAM).

We have performed a detailed characterization of the oxide epitaxial crystallization by employing a quantification procedure that involves two-dimensional X-ray diffraction (2D-XRD) measurements. The physical properties of the films are also evaluated, and the results are correlated with equivalent samples produced by conventional thermal treatments. Finally, the thermal evolution inside the oxide heterostructures during irradiation is evaluated by finite element simulations. These findings strengthen our experimental results and provide a better understanding of laser photoinduced crystallization of functional oxide thin films.

2. EXPERIMENTAL SECTION

2.1 Material preparation. The oxide thin films investigated in this work were deposited by the chemical solution deposition (CSD) method on (001)-oriented Y$_2$O$_3$:ZrO$_2$ (YSZ), LaAlO$_3$ (LNO) and SrTiO$_3$ (STO) single crystal substrates (Crystec GmbH) of 5 x 5 mm$^2$ and 0.5 mm in thickness, as it will be described next. Firstly, Ce$_{0.9}$Zr$_{0.1}$O$_{1.95}$ (CZO) precursor solutions with a concentration of 0.25 M were prepared by adding cerium (III) and zirconium (IV) acetylacetonate salts (Sigma-Aldrich) in propionic acid and stirring the mixture at 50 °C for 30 min. The solution was then spun at 6000 rpm for 2 min onto thoroughly cleaned (001) YSZ substrates. The metalorganic films were heated at 300 °C for 30 min with a tubular furnace to fully decompose the organic material obtaining a nanocrystalline CZO film before the laser irradiation. Secondly, stoichiometric 0.2 M LaNiO$_3$ (LNO) solutions were synthesized from lanthanum (III) nitrate and nickel (II) acetate salts (Sigma-Aldrich) diluted in 2-methoxyethanol and refluxed at 125 °C for a few hours. Deposition by spin coating on (001) STO substrates was done with the same conditions as for CZO. Full removal of organic residues for the metalorganic LNO precursor films was achieved by thermal annealing at 350 °C for 30 min using a tubular furnace. Thirdly, Ba$_{0.8}$Sr$_{0.2}$TiO$_3$ (BST) precursor solutions with a 0.3 M concentration were prepared by diluting barium (II) and strontium (II) acetate salts (Sigma-Aldrich) in propionic acid for 3 h, and then adding titanium (IV) isopropoxide. Acetylacetonate was used as stabilizing agent. BST solutions were spin-coated at 6000 rpm for 2 min on (001) Cr$_2$O$_3$/LNO / (001) LAO buffered substrates, and fully decomposed at 450 °C for 10 min. The (001) LNO epitaxial buffer layers with thicknesses of ~25 nm were produced by thermal annealing of metalorganic films at 700 °C, 10 °C min$^{-1}$ for 1 h in oxygen. Finally, the procedure used to synthesize 0.3 M La$_{1-x}$Sr$_x$MnO$_3$ (LSMO) precursor solutions consisted of mixing lanthanum (III), strontium (II) and manganese (II) acetates in acetic acid, and stirring the mixture at 50 °C for 10 min. Again, the solution was spun at the conditions reported before onto (001) STO substrates. The metalorganic films were then heated up to 300 °C and
Pulsed laser annealing (PLA) of the amorphous/nanocrystalline oxide films was done with a Brilliant Nd:YAG laser (Quantel) working at a wavelength of 266 nm, and sending pulses that last 3 ns at a repetition rate of 10 Hz. The spatial distribution of the laser beam was almost a Gaussian of approximately 6 mm in diameter. Thus, the laser fluence, defined as the pulse energy per unit area, radially decreased from its maximum value at the beam center, being twice the average fluence (i.e., the pulse energy divided by the beam area). Inhomogeneous crystallization that could result from the Gaussian beam was reduced by irradiating regularly spaced locations separated 1 mm from each other, and providing a beam overlapping of ~80%, as reported previously.

We estimated that the overall accumulated pulses/site due to overlapping was around 13 times the one applied at each location. Films were irradiated in air at selected laser fluences by tuning the incoming laser energy. The substrate base temperature during irradiation was fixed for all experiments at 400 °C with a precision of ±1 °C using a PID controlled heater (Watlow Ultramic 600).

2.2 Characterization. Atomic force microscopy (AFM) was used to characterize films morphology with an Agilent 5000 system operating in intermittent contact mode. The topographic measurements obtained were analyzed with the MountainsMap 7.0 software (Digital Surf). X-ray diffraction (XRD) θ-2θ analyses were conducted to evaluate the crystallographic structure of samples. Also, a quantitative analysis of the epitaxial fraction was carried out using a procedure based on two-dimensional (2D) XRD measurements, detailed later. Pole figure measurements were conducted by integrating 360 2D XRD frames collected at steps of Δθ=1° for 20 s each frame. Data acquisition was done with a Rigaku RotaFlex RU-200BV diffractometer and a GADDS system from Bruker equipped with a 2D detector. High resolution transmission electron microscopy (HRTEM) investigations were employed to complete our crystallization studies. FEI Tecnai F20 and JEOL J2100F microscopes operated at 200 kV, with lateral resolutions of 0.14 nm, provided high resolution images of cross-sectional specimens that were prepared by mechanical polishing and ion milling. In addition, we characterized different physical properties of the samples. We measured the electrical resistivity of LNO films using a physical properties measurement system (PPMS) from Quantum Design Inc., setting the electrical contacts in a four-probe configuration and following the van der Pauw method. Magnetization measurements of LSMO films were carried out with a commercial MPMS XL-7T superconducting quantum interference device (SQUID) DC-magnetometer (Quantum Design, Inc.) with the applied magnetic field parallel to the substrate plane. The optical properties of fully decomposed films such as reflectance and transmittance (Figure S1) were measured with a Varian Cary 500 UV-Vis-NIR spectrophotometer. The Denton method was then used to calculate the refractive index (n), extinction coefficient (κ), absorption coefficient (α=4πκ λ−1) and optical penetration depth (l=α−1), at each wavelength λ. Finally, we simulated the thermal behaviour induced in the oxide heterostructures by laser annealing, COMSOL 4.4 Multiphysics software was employed to solve the transient heat equation with the finite element method. Additional details on the simulation procedure have already been described in the Supporting Information and in Refs. 23, 33, 34, 49. Further optical parameters, as well as different thermophysical properties of films and substrates used in the calculations have already been reported in Refs. 10, 33, 34, 47, 52-66 and are summarized in the Supporting Information (Table S1).

3. RESULTS AND DISCUSSION

3.1 Laser crystallization of oxide films. Two dominant effects are usually considered during laser irradiation, namely photochemical and photothermal interactions. On the one hand, photochemical effects involve the direct breaking of chemical bonds which occur typically when the laser photon energy is larger than the energy needed to dissociate chemical bonds. These mechanisms have interaction times shorter than picoseconds. On the other hand, photothermal interactions, much longer in duration (10−7-10−11 ns), are caused by the thermalization of excited electrons. The amorphous/nanocrystalline films produced after the pyrolysis of metalorganic precursors are fully decomposed since no presence of organic residues or C-impurities are detected by FTIR spectroscopy. Then, one can assume that these films mostly consist of metal-oxygen bonds; i.e., Ce-O, Zr-O, La-O, Ni-O, Ba-O, Sr-O, Ti-O, Mn-O; with dissociation energies ranging from 392 to 799 kJ mol−1 (4.1 to 8.3 eV/bond). Since the laser photons have an energy of ~4.7 eV at 266 nm, we can expect the presence of photochemical interactions in the oxide layers investigated. Nevertheless, we suspect that they will not be as significant as photothermal ones because the laser pulse duration of 3 ns is much longer than electron thermalization times. It is also worth mentioning that any undetected organic bonds that could survive the pyrolysis treatment, mainly C-C, C-O and C-H with dissociation energies of 3.6-4.3 eV/bond, would be photochemically/photothermally removed during the initial stages of irradiation.

The heat produced during irradiation is partially determined by the amount of laser photons absorbed in the film, which is expressed on the optical penetration depth (l=α−1). The values of l at λ=266 nm, extracted from Figure S1, are approximately 32, 79, 48 and 42 nm for CZO, LNO, BST and LSMO pyrolyzed films, respectively, while their thicknesses determined from X-ray reflectometry (XRR) measurements (Figure S2) are 26, 39, 43 and 45 nm. Then, it can be estimated from the Beer-Lambert law that a 54, 40, 57 and 66 % of the incoming radiation intensity is absorbed by CZO, LNO, BST and LSMO pyrolyzed...
films. The remaining radiation is transmitted and absorbed by the substrates which will have an important contribution to the overall heating process. The photothermally-generated heat produced from the radiation absorbed, as well as the laser annealing conditions is assessed by solving the heat equation with numerical simulations. Figure 1a shows the simulated temperature profiles for 40-nanometer thick LNO films on STO substrates irradiated with a single laser pulse at fluences of 20, 30 and 40 mJ cm\(^{-2}\) and a substrate temperature of 400 °C. The use of a substrate base temperature has been demonstrated advantageous to decrease film RMS roughness, to improve film surface homogeneity and degree of crystallization, and prevent or reduce crack formation.\(^{23-49}\) These phenomena have been linked to the boost in the maximum temperatures reached, the decrease of the temperature gradient between the film surface and the interface with the substrate, but also due to longer heating times at temperatures promoting crystallization, i.e. above 600 °C, as shown in Figure S3. Equivalent simulations for CZO on YSZ, BST on LNO/LAO and LSMO on STO can be found in the Supporting Information (Figure S4). It can be seen that very fast thermal cycles lasting from tens to hundreds of nanoseconds are generated in the films with each laser pulse. The maximum temperatures reached at the film surfaces range from 1150-1900 °C for CZO, 750-1150 °C for LNO, 800-1200 °C for BST, and 1000-1500 °C for LSMO (Figure 1b) and the heating/cooling rates achieve up to ~10\(^{10}\) °C s\(^{-1}\). The fast laser treatments induce large temperature differences from 50 to 400 °C between the film surface and film/substrate interface. These differences lead to temperature gradients in the films over 10\(^9\) °C m\(^{-1}\). The effective heating time for a single pulse \(t_{eff}\) is used to estimate the effective duration for photothermal laser heating and it has been defined as the time duration the film is above 600 °C (assumed as the minimum temperature required for crystallization). Figure S5 shows that the values of \(t_{eff}\) for a single laser pulse increase with the laser fluence and greatly depend on the system due to the different optical and thermophysical parameters of the different oxide components. For instance, the effective heating time for CZO is ~5 times longer than for BST at 40 mJ cm\(^{-2}\).

Pulsed laser annealing is performed on CZO, LNO, BST and LSMO pyrolyzed films with an 80% of beam overlapping and a substrate temperature of 400 °C, as mentioned before. Laser fluences of 30 mJ cm\(^{-2}\) (LNO and LSMO) and 40 mJ cm\(^{-2}\) (CZO and BST) are carefully selected to achieve solid-state laser crystallization, i.e. without exceeding the melting temperature of each oxide (Table S1). The applied number of pulses per site ranges from 1000 to 20000 pulses/site. The surface morphology of pyrolyzed oxide films is very flat with RMS roughnesses of 0.3-0.4 nm (Figure S6). After laser irradiation, the morphology of CZO films present grains of few tens of nanometers in size that grouped in domains up to 100-200 nm after accumulating a large number of pulses. Their RMS roughness after irradiation is kept constant with the number of pulses at 0.7-0.8 nm. In contrast, LNO, BST and LSMO films consist of periodical structures, also known as ripples, with sizes of 200-300 nm. The formation of these structures is a widely observed effect on laser irradiation of surface materials, which origin is ascribed to complex
scattering and interference mechanisms\textsuperscript{30,68,69} that has not been assessed in this work. The film roughnesses for LNO, BST and LSMO after applying 2500 pulses/site are 2.3, 8.5 and 2.9 nm, respectively, and experienced a notable increase with the number of pulses up to 4.8, 13.9 and 4.0 nm (20000 pulses/site) as ripples developed (Figure S6). Typically, thermally annealed films have much more flat surfaces,\textsuperscript{70,71} and thus, such rough morphology will have an influence on the functional properties of films as it will be detailed later.

Figure 2 displays the XRD diffractograms of CZO/YSZ, LNO/STO, BST/LNO/LAO and LSMO/STO heterostructures irradiated at the aforementioned experimental conditions. Firstly, we identify the (002) peaks of YSZ, STO and LAO substrates located at 35.0º, 46.5º and 48.0º, respectively, and weak peaks associated to their K\textsubscript{β} signal at 31.4º, 41.8º and 43.1º. The (002) LNO reflection of the LNO buffer layer is also seen in the BST/LNO/LAO system. Regarding laser annealed films, we detect the (002) epitaxial reflections of CZO at 33.4º, LNO at 47.3º, BST at 45.9º and LSMO at 46.9º. The intensity of these epitaxial peaks increases with the number of pulses. A very weak polycrystalline peak is identified at 28.8º for CZO/YSZ heterostructures, i.e. (111) CZO, after accumulating 1000 pulses/site that seems to disappear when more pulses are applied (Figure 2a). No apparent peaks associated to polycrystalline material are observed for the other oxide systems. Therefore, these results indicate that we are able to induce epitaxial crystallization from the initial amorphous/nanocrystalline material by laser annealing.

A more detailed study of CZO and BST films grown on YSZ and LNO/LAO, respectively, conducted by HRTEM is presented in Figure 3. Both samples are irradiated at 40 mJ cm\textsuperscript{-2} and accumulating 20000 pulses/site. On the one hand, Figure 3a shows that the region close to the CZO/YSZ interface grows epitaxially. Specifically, we estimate that the epitaxial thickness is around a 40-50\% of the whole CZO film. The remaining film consists of polycrystalline grains, as inferred from the power spectrum of the image. Additionally, the epitaxial region of the CZO film seems fully relaxed on top of the YSZ substrate with a lattice parameter equivalent to the bulk (a\textsubscript{CZO,exp}=a\textsubscript{CZO,bulk}=5.385 Å, a\textsubscript{YSZ,bulk}=5.143 Å). On the other hand, Figure 3b shows that the BST film grows completely epitaxial on the (001) LNO buffer layer, as evidenced by the fast Fourier transform. These studies also reveal that the epitaxial LNO buffer layer is fully strained on top of the LAO substrate (a\textsubscript{LNO,exp}=a\textsubscript{LAO,bulk}=3.788 Å, a\textsubscript{LNO,bulk}=3.850 Å). Consequently, the BST lattice parameter is also compressed with respect to its bulk value (a\textsubscript{BST,bulk}=3.993 Å). In this case, the compression is of -2.7\% (a\textsubscript{BST,exp}=3.884 Å) indicating that the BST film is only partially strained.

The local nature of TEM required a more general method to evaluate the amount of epitaxial material in the films. In particular, we measure the epitaxial fraction following a procedure based on 2D-XRD experiments already described in Refs. \textsuperscript{4,23,49}. Basically, it consists of performing a measurement at fixed φ, 2θ, χ and ω angles with a 2D detector to acquire multiple crystallite orientations of a film simultaneously. The reflections selected to perform the analyses are the (011) orientation for LNO, BST and LSMO, and the (022) orientation for CZO which correspond to values of ω~15º, χ~45º and 2θ~47.73º (CZO), 32.78º (LNO), 31.67º (BST) and 32.66º (LSMO). Then, we quantify the amount of (001) film crystallites aligned with the (001) substrate orientation (I\textsubscript{epitaxial}) with respect to other film orientations (polycrystalline material - I\textsubscript{random}) employing the following expression:

\[
\frac{I_{\text{random}}}{I_{\text{epitaxial}}} = \frac{4\pi(360/\chi)^{\text{exp}}}{\theta_0^{\text{exp}}} \frac{\theta_0^{\text{epi}}}{\theta_0^{\text{exp}}} \]

(1)
Figure 2. θ-2θ XRD measurements of laser-crystallized films: (a) CZO on YSZ, (b) LNO on STO, (c) BST on LNO/LAO and (d) LSMO on STO. A fluence of 40 mJ cm\(^{-2}\) is used for CZO and BST films, whereas LNO and LSMO films are irradiated at 30 mJ cm\(^{-2}\). The number of accumulated pulses/site ranges from 1000 to 20000 for CZO films, and from 2500 to 20000 pulses for LNO, BST and LSMO films as indicated.

Figure 3. HRTEM characterization of: (a) CZO on YSZ, and (b) BST on LNO/LAO. Samples are grown at 40 mJ cm\(^{-2}\), applying 20000 pulses/site. Colored frames correspond to the different areas investigated.

where \(I_{\text{epi}}^{\text{exp}}\) and \(I_{\text{ring}}^{\text{exp}}\) correspond to the diffracted intensities of the epitaxially textured and polycrystalline ring phases, and \(\Delta \chi\) is the angular range accounting for misoriented crystallites. Percent values are calculated considering that \(I_{\text{random}}+I_{\text{epitaxial}}=100\) (%). Figure S7 illustrates the raw data used in the epitaxial fraction quantification of CZO/YSZ, LNO/STO, BST/LNO/LAO and LSMO/STO heterostructures after laser irradiation. The epitaxial component of films and substrates is depicted as a central “spot”, whereas the ring corresponds to the polycrystalline material fraction. No secondary phases are found. Figure 4a displays the quantification of the epitaxial fraction from 2D-XRD measurements in Figure S7 for laser annealed CZO, LNO, BST and LSMO films as a function of the overall effective heating time which is calculated by multiplying the number of accumulated pulses by the effective heating time of a single pulse. The beam overlapping is also considered in the calculation. Since the amount of material available to transform is fixed by the solution deposition, the data presented is fitted assuming that the epitaxial transformation follows a self-limited growth behavior similar to that reported for grain growth by Rupp et al.\(^72,73\) and described in the Supporting Information.

As we hinted before, the degree of epitaxy increases with the effective heating time, i.e. as more pulses/site are accumulated. In particular, the epitaxial fraction for CZO films rises from ~20% at 0.4 ms (1000 pulses/site) to 50-55% at 7.2 ms (20000 pulses/site). It is worth noticing that these values are quite similar to the estimation made from the epitaxial film thickness observed by HRTEM (Figure 3a). We predict from data fitting that it would take around 140000 pulses/site (~53 ms) to obtain a completely epitaxial CZO film. In contrast, full epitaxial transfor-
mation of LNO, BST and LSMO films is obtained after few milliseconds, i.e. between 1.3 and 2.4 ms, which we achieve experimentally by accumulating between 10000 and 20000 pulses/site. These results are around one order of magnitude faster than for CZO. Figure S8 presents 2D-XRD (022)-centered pole figure measurements for CZO, LNO, BST and LSMO films annealed by laser at fluences of 30-40 mJ cm\(^{-2}\) and 20000 pulses/site. We observe that CZO has four poles at \(\chi=45^\circ\) corresponding to the (002) orientation characteristic of epitaxial growth, but also we detect other signals that can be attributed to the presence of random grains in the film. On the other hand, LNO, BST and LSMO films only show the four poles at \(\chi=45^\circ\) which demonstrates their full epitaxial growth.

We can also extract the epitaxial growth rate evolution with the effective time (Figure 4b) by deriving the fitted curves in Figure 4a with respect to the effective heating time and multiplying by the final film thickness i.e. around 20, 25, 35 and 30 nm for CZO, LNO, BST and LSMO, respectively. Interestingly, we see that the epitaxial growth rates have an initial value that decreases with the effective heating time as the epitaxial growth proceeds. This suggests that the driving force towards epitaxial crystallization is higher at the beginning and it is reduced as less polycrystalline material is able to transform. The initial values for the epitaxial growth rates, presented in Figure S9a, are approximately 2.5×10\(^{-3}\) nm s\(^{-1}\) for CZO, whereas LNO, BST and LSMO films have epitaxial growth rates which are almost two orders of magnitude higher, i.e. 7.5×10\(^{-3}\), 7.0×10\(^{-4}\) and 9.8×10\(^{-5}\) nm s\(^{-1}\), respectively. The different optical and thermal response of films and substrates, as well as the probable distinct contribution of photochemical interactions could explain this variation in growth rates. Despite that, a large difference of 4-6 orders of magnitude is detected when we compare these values with the epitaxial growth rate of thermally treated films which are between 0.01 and 0.1 nm s\(^{-1}\).\(^{33}\) The formation of a crystalline phase from amorphous/nanocrystalline material is driven by a decrease in the Gibbs free energy, but also by a reduction in the surface to volume ratio of polycrystalline grains. In addition, the conversion from polycrystalline material to epitaxial grains is achieved by grain boundary reconstruction typically involving a thermally-activated diffusion process. We calculate the diffusion coefficients of the epitaxial laser growth from Figure 4a applying the aforementioned self-limited growth model,\(^{33}\)\(^{75}\) described in the Supporting Information. As observed in Figure S9b, the effective epitaxial diffusion coefficients are approximately 1.3×10\(^{-19}\), 5.2×10\(^{-19}\), 6.1×10\(^{-19}\) and 7.5×10\(^{-19}\) m\(^2\) s\(^{-1}\) for CZO/YSZ, LNO/STO, BST/LNO/LAO and LSMO/STO heterostructures, respectively. The diffusion coefficient of CZO/YSZ is around one order of magnitude smaller than those of the oxide systems studied, whereas these values are around 5-6 orders of magnitude larger than those of thermal treatments (≈10\(^{-19}\)-10\(^{-18}\) m\(^2\) s\(^{-1}\)).\(^{33}\) Although laser treatments usually develop higher temperatures, i.e. thermal treatments reach up to 1000 °C, as shown in Figure 1, it has been previously demonstrated that the temperature differences between thermal and laser treatments are insufficient to induce such variation of diffusion coefficients between thermal and laser annealing.\(^{33}\) However, external driving forces such as temperature gradients, electric fields, etc., could highly influence atomic diffusion.\(^{74}\) In particular, the contribution of temperature gradients on atomic diffusion for thermal treatments is insignificant (constant temperature in overall system) compared to laser irradiation where temperature gradients as high as 10\(^{6}\) °C m\(^{-1}\) can be reached. Thus, it would be feasible for the large temperature gradients to act as intense driving forces towards the enhancement of the atomic diffusion for epitaxial growth.\(^{33}\) The Johnson-Mehl-Avrami-Kolmogorov (JMAK) theory describes the volume fraction of the crystallized phase, \(X\), in isothermal conditions, and assuming that nucleation and growth rates are time independent with a phenomenological equation \(^{75-78}\):

\[
X = 1 - \exp\left[-\left(Kt\right)^{m+1}\right]
\]

(2)

where \(m+1\) is the Avrami exponent, and \(K\) is the rate constant per mole given by:

\[
K = K_0 \exp\left(-\frac{Q}{k_B T}\right)
\]

(3)

where \(Q\) is the activation energy, \(k_B\) is the Boltzmann constant, \(T\) is the temperature, and \(K_0\) is the attempt frequency (≈10\(^{-12}\) s\(^{-1}\) for laser annealing). Farjas \textit{et al.} modified the JMAK equation to account for non-isothermal situations such as pulsed laser annealing\(^{79}\):

\[
\frac{dX}{dt} = (m + 1) \cdot C \cdot K \cdot (1 - X) \cdot [-\ln(1 - X)]^{m/m+1}
\]

(4)
where \( C \) is a constant that depends on \( m \), and the activation energies for nucleation and growth (\( E_N \) and \( E_G \)). The activation energies \( Q \) (\( = (E_N + mE_G)/(m+1) \)) for the different laser irradiated films can be extracted by combining Equation 3 and 4. In our calculations, we assume that \( C=1 \) (\( E_N = E_G \)), \( m=2,3 \) (2D and 3D growth)\(^{87,88} \) and average irradiation temperatures of 1193, 791, 839 and 867 \(^\circ\)C for CZO, LNO, BST and LSMO, respectively. These average temperature values have been extracted from Figure 1a and 54 for temperatures above 600 \(^\circ\)C. The calculated activation energies \( Q \) are 3.0-3.2 eV (CZO), 1.9-2.1 eV (LNO), 2.0-2.2 eV (BST) and 2.1-2.2 eV (LSMO). These values seem equivalent to those determined for some sol-gel derived oxides, i.e. 2.4 eV for YSZ, 3.0-3.8 eV for multilite.\(^{50,83} \) These values indicate that the thermal energy required for the activation of nucleation and crystallization is quite high. In addition, they are in accordance with the results of diffusion coefficients calculated before. Typically, crystallization processes controlled by bulk diffusion have energy values of few eV, while energies in the range of 0.1-1 eV are usually indicative of surface or grain boundary diffusion mechanisms controlling crystallization.\(^{78} \) Activation energies around 4.7 eV have been reported for Gd-doped CeO\(_2\) films, and between 5.1 and 6.8 eV for YSZ films grown by PLD.\(^{78,85} \) Both works attributed such high activation energies to bulk diffusion. In contrast, activation energies as low as 1.3 eV have been attributed to grain boundary diffusion in CGO films by Rupp et al.\(^{72} \) It seems then that bulk diffusion is the main mechanism controlling film growth. Despite that, grain boundary diffusion may also be involved in the crystallization of our films. The contribution of volume diffusion should be larger on the crystallization of CZO films as compared to LNO, BST and LSMO films due to the larger activation energies.

### 3.2 Functional properties of laser annealed films.

The viability of pulsed laser annealing as a technique used in the production of epitaxial oxide thin films is also tested by measuring their functional properties, and comparing them with equivalent epitaxial films obtained by thermal treatments. Specifically, we measure the electrical resistivity of LNO films grown on STO by PLA at 30 mJ cm\(^{-2}\) applying 20000 pulses/site in air, and by thermal annealing at 700 \(^\circ\)C, 10 \(^\circ\)C min\(^{-1}\) for 1 h in O\(_2\).

These microstructural defects accumulated in the laser annealed samples could cause an increase of the structural disorder and so of the electrical resistivity.\(^{86} \) It should be emphasized that the effective heating time is orders of magnitude shorter for laser annealing (0.4 ms) compared to thermal treatments (1 h). Thus, further irradiation providing higher crystallinity, i.e. larger grain sizes, and grain boundary healing should lead to lower resistivity values in the range of thermal treatments.

![Figure 5. Temperature dependence of the electrical resistivity measured for LNO films on STO. Films are grown by laser annealing at 30 mJ cm\(^{-2}\) applying 20000 pulses/site in air, and by thermal annealing at 700 \(^\circ\)C, 10 \(^\circ\)C min\(^{-1}\) for 1 h in O\(_2\).](image)

In the case of BST on LNO/LAO, the local ferroelectric performance has been evaluated previously by conducting PFM measurements.\(^{34} \) The study reveals similar PFM behavior between laser and thermally annealed samples. However, it should be noticed that the presence of ferroelectricity cannot only be inferred from PFM measurements since electrostatically-induced charge migration can be induced by the AFM tip,\(^{80} \) and thus, additional measurements should be conducted to confirm the presence of ferroelectricity.

Finally, we investigate the magnetic properties of LSMO films on STO (Figure 6). In this case, the samples examined were obtained by laser annealing at 30 mJ cm\(^{-2}\), a substrate temperature of 400 \(^\circ\)C, and 2500 and 10000 pulses/site. Irradiation was done in air as mentioned before. These films are compared with two samples prepared by CSD and thermal annealing at 1000 \(^\circ\)C, 3 \(^\circ\)C min\(^{-1}\) for 1 h in air and oxygen, respectively. We measure the magnetization (\( M \)) dependence with temperature (\( T \)) at a constant magnetic field of 5 kOe, and its dependence with the magnetic field (\( H \)) at 35 K using a SQUID magnetometer. Figure 6a shows that the films grown by laser annealing after accumulating 2500 and 10000 pulses/site have a saturation magnetization (\( M_s \)) of 340 and 515 kA m\(^{-1}\), respectively. This increase is due to the improvement of crystallization. Instead, the film prepared by thermal annealing in O\(_2\) has a saturation magnetization (\( M_s \)) identical to the bulk value (\( \sim 590 \) kA m\(^{-1}\)) whereas the films produced at the same annealing conditions in air presents a \( M_s \) somewhat smaller (\( \sim 545 \) kA m\(^{-1}\)). The lower value of magnetization for laser treated films with a large number of accumulated pulses as compared to the thermal an-

Figure 5. Temperature dependence of the electrical resistivity measured for LNO films on STO. Films are grown by laser annealing at 30 mJ cm\(^{-2}\) applying 20000 pulses/site in air, and by thermal annealing at 700 \(^\circ\)C, 10 \(^\circ\)C min\(^{-1}\) for 1 h in O\(_2\).
nealed ones could be mostly explained by the atmosphere used during irradiation, as well as a small contribution of the presumably lower degree of crystallization, leading to smaller crystallite sizes as compared to thermal treatments. We also see an increase in saturation magnetization with the number of pulses, i.e. the effective heating time, which is associated to a boost of the epitaxial fraction (Figure 4a). The sample irradiated with 2500 pulses/site ($t_{\text{eff}}$=0.1 ms) has an epitaxial fraction of 50-60%, while full epitaxy is achieved after 10000 pulses/site ($t_{\text{eff}}$=1.3 ms). An additional reduction factor would be related to an influence of the microstructure of the laser-crystallized LSMO films on the saturation magnetization. Our results are in agreement with those reported by Rivas et al., where the magnetization drastically decreases as the grain size does. Nevertheless, the Curie temperature ($T_c$) of laser irradiated films, which also increases with the laser effective heating time, is just few tens of degrees lower than the bulk value (~360 K). In Figure 6b, we present the magnetic hysteresis loops that illustrate the ferromagnetic behavior of LSMO films. Interestingly, laser processed samples have loops with coercive fields $H_c$ of around 300 Oe which are wider than those for thermally annealed samples. Coercive fields usually have a strong dependence on the film microstructure, and tend to increase as the amount of defects in the epitaxial layer does. Although further microstructural characterization is required, it can be expected that laser-crystallized films should present more defects than the thermally annealed ones due to the fast processing times achieved. In addition, we observe a general enhancement of the magnetic properties of LSMO films with longer effective heating times also confirming their relation with the sample crystalline quality.

4. CONCLUSIONS

Pulsed laser annealing of CSD-derived coatings has been demonstrated to achieve predominantly epitaxial growth of functional oxide heterostructures. The methodology is rather simple and laser irradiations are conducted in air. Despite some optimization of the surface morphology and further irradiation leading to grain boundary healing are still required, we have shown the potential of PLA achieving the crystallization of epitaxial oxide thin films with functional properties close to those reported for conventional thermal treatments, but with orders of magnitude shorter effective heating times. The atomic diffusion coefficients and epitaxial growth rates are orders of magnitude larger than those of thermal treatments. The fast nature of laser-induced heating processes and the development of large temperature gradients is considered to be the main cause of the observed huge growth kinetics. In addition, the fast heating rates are likely preventing excessive coarsening of random orientations which contributes to a fast epitaxial growth. The activation energies for crystallization show smaller values than those obtained with thermal treatments, and indicate that bulk diffusion has a main role in film crystallization. The influence of grain boundary diffusion mechanisms cannot be com-
pletely discarded given the values of activation energies are not far from the energy range associated to grain boundary diffusion. An additional advancement of this method resides in the ability to locally irradiate (and crystallize) precursor layers. Therefore, we identify the industrial implementation of this technique, by means of direct laser-writing or laser-lithography, as a promising route for future rapid, cost-effective and scalable fabrication of high performance electronic devices.

ASSOCIATED CONTENT

Supporting Information
Optical properties of decomposed oxide precursor layers, optical and thermal material properties employed in simulations, photothermal simulations, AFM images of surface morphology, θ-2θ, XRR and 2D-XRD measurements. A theoretical description of the self-limited growth is also included, as well as the growth rates and diffusion coefficients extracted. “This material is available free of charge via the Internet at http://pubs.acs.org.”

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Notes
The authors declare no competing financial interests.

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Ultrafast epitaxial growth of oxide thin films is demonstrated by pulsed laser annealing. The fast crystallization achieved by photo-induced interactions, i.e. orders of magnitude larger than thermal treatments, is mainly driven by bulk diffusion. The films also reveal good functional properties in some cases equivalent to those produced by thermal treatments.